

LIST OF ART CITED BY APPLICANT  
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Gurtej S. Sandhu et al.FILING DATE (PRIORITY)  
August 15, 2002GROUP (PRIORITY)  
2813

## U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	5,783,716	07-1998	Baum et al.			
	AB	6,376,327 B2	04-2002	Sandhu et al.			
	AC	5,510,158	04-1996	Hiramoto et al.			
	AD	6,103,567	08-2000	Shih et al.			
	AE	6,432,793 B1	08-2002	Reinberg			
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	AI	6,150,209	11-2000	Sun et al.			
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	AK	6,461,982	10-2002	DeBoer et al.			
	AL	4,839,196	06-1989	Itoh			
	AM	5,547,706	08-1996	Thaler			

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		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AN	JP06115912 A	04-1995	JP (abstract only)			x	
	AO	JP02001185548 A	07-2001	JP (abstract only)			x	
	AP	JP01262680 A	12-1986	JP			x	
	AQ	JP05186875A	07-1993	JP				

## OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

	AR		Cranciu et al., "Low Temperature Growth of Barium Strontium Titanate Films by Ultraviolet-Assisted Pulsed Laser Deposition", Mat. Res. Symp. Vol. 617, pgs. J3.21.1-J3.21.6, 2000. Year is sufficiently early such that the month is not an issue.
	AS		

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